



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Abdurrahman Sezginer et al.

Application No.: 10/613,378

Filed: July 3, 2003

For: OVERLAY METROLOGY METHOD  
AND APPARATUS USING MORE  
THAN ONE GRATING PER  
MEASUREMENT DIRECTION

Confirmation No.: 7200

Group Art Unit: Unknown

Examiner: Unknown

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(37 CFR 1.8(a))

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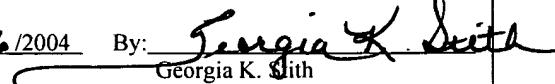
**CERTIFICATE OF MAILING**

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STALLMAN & POLLOCK LLP

Dated: 06/16/2004

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Respectfully submitted,

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